

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

NOV 26 2004

Applicant

Klaus F. Schuegraf et al.

SELECTIVE SPACER TO PREVENT METAL OXIDE FORMATION DURING POLYCIDE  
REOXIDATION

Docket No.: 303.278US1  
Filed: July 30, 1997  
Examiner: Ori Nadav

Serial No.: 08/902,809  
Due Date: November 23, 2004  
Group Art Unit: 2811

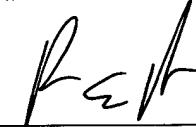
**Mail Stop Amendment**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

We are transmitting herewith the following attached items (as indicated with an "X"):

A return postcard.  
 An Amendment and Response (9 Pages).  
 A Communication Concerning Related Applications (2 pgs.).

If not provided for in a separate paper filed herewith, Please consider this a PETITION FOR EXTENSION OF TIME for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

By:   
Atty: Robert E. Mates  
Reg. No. 35,271

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 23 day of November, 2004.

Name

Tina Kohaut

Signature

Z-UL

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

(GENERAL)



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Klaus F. Schuegraf et al. Examiner: Ori Nadav  
Serial No.: 08/902,809 Group Art Unit: 2811  
Filed: July 30, 1997 Docket: 303.278US1  
Title: SELECTIVE SPACER TO PREVENT METAL OXIDE FORMATION DURING  
POLYCIDE REOXIDATION

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COMMUNICATION CONCERNING RELATED APPLICATION(S)

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Applicants would like to bring to the Examiner's attention the following related application(s) in the above-identified patent application:

<u>Serial/Patent No.</u>	<u>Filing Date</u>	<u>Attorney Docket</u>	<u>Title</u>
10/789890	February 27, 2004	303.278US2	METHOD TO PREVENT METAL OXIDE FORMATION DURING POLYCIDE REOXIDATION
08/902808 5925918	July 30, 1997	303.192US1	GATE STACK WITH IMPROVED SIDEWALL INTEGRITY
09/097353 5998290	June 15, 1998	303.192US2	METHOD TO PROTECT GATE STACK MATERIAL DURING SOURCE/DRAIN REOXIDATION

**COMMUNICATION CONCERNING RELATED APPLICATIONS**

Serial Number: 08/902,809

Filing Date: July 30, 1997

Title: SELECTIVE SPACER TO PREVENT METAL OXIDE FORMATION DURING POLYCIDE REOXIDATION

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Dkt: 303.278US1

09/323178  
6075274

May 28,  
1999

303.192US3

SEMICONDUCTOR DEVICES HAVING  
GATE STACK WITH IMPROVED  
SIDEWALL INTEGRITY

Respectfully submitted,

KLAUS F. SCHUEGRAF ET AL.

By Applicants' Representatives,

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.  
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Date 23 November 2004

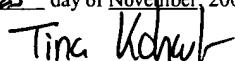
By \_\_\_\_\_

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